

09-12-2002

Form-PTO-1595  
1-31-92

TR



CORDATION

Atty. Docket: 03500.016478.

To the Director, U.S. Patent :

102219044

ached original documents or copy thereof.

1. Name of conveying party(ies):

Takaharu Kondo, Masafumi Sano, Akira Sakai, Tadashi Sawayama, Ryo Hayashi, Shuichiro Sugiyama, Hiroyuki Ozaki and Yoshinori Sugiyama.

2. Name and address of receiving party(ies):

Name: CANON KABUSHIKI KAISHA

Foreign Address: 30-2, Shimomaruko 3-chome, Ohta-ku

Tokyo, Japan

Additional name(s) of conveying party(ies) attached?

☐ Yes☒ No

3. Nature of conveyance:

☒ Assignment☐ Merger☐ Security Agreement☐ Change of Name☐ Other

Domestic Address: \_\_\_\_\_

City: \_\_\_\_\_ State \_\_\_\_\_ ZIP \_\_\_\_\_

Additional name(s) & address(es) attached? ☐ Yes ☒ No

4. Application number(s) or patent number(s):

If this document is being filed together with a new application, the execution date of the application is: \_\_\_\_\_

A. Patent Application Number: 10/166,759

Filing Date: June 12, 2002

B. Title of Invention:

SILICON-BASED FILM FORMATION PROCESS, SILICON-BASED FILM, SEMICONDUCTOR DEVICE, AND SILICON-BASED FILM FORMATION SYSTEM

Additional numbers attached?

☐ Yes☒ No

5. Name and address of party to whom correspondence concerning document should be mailed:

Name: Fitzpatrick, Cella, Harper &amp; Scinto

30 Rockefeller Plaza

New York, New York 10112-3801

Telephone No.: (212) 218-2100

Facsimile No.: (212) 218-2200

6. Number of applications and patents involved:

One

7. Total fee (37 CFR 3.41): .... \$ 40.00

☒ Enclosed☐ Authorized to be charged to deposit account

8. Deposit account number (for deficiency or excess)

06-1205

(Attach duplicate copy of this page if paying by deposit account):

DO NOT USE THIS SPACE

9. Statement and signature.

*To the best of my knowledge and belief, the foregoing information is true and the attached is the original document or is a true copy of the original document.*

Jason M. Okun

Name of Person Signing

Signature

September 5, 2002

Date

Total number of pages including cover sheet, attachments, and documents: 3

09/11/2002 LNUJELLER 00000192 10166759

01 FC:581  
Form #122

40.00 00

NY\_MAIN 288196 v 1

PATENT  
REEL: 013268 FRAME: 0557

**JOINT**  
(AFTER APPLICATION FILED)

# ASSIGNMENT OF PATENT RIGHTS FOR THE UNITED STATES

FOR VALUE RECEIVED, WE, Takaharu Kondo, Masafumi Sano, Akira Sakai, Tadashi Sawayama, Ryo Hayashi, Shuichiro Sugiyama, Hiroyuki Ozaki and Yoshinori Sugiura

hereby sell, assign, transfer and convey unto CANON KABUSHIKI KAISHA

a corporation of Japan

having a place of business at

3-30-2, Shimomaruko, Ohta-ku, Tokyo, Japan

its successors, assigns and legal representatives (hereinafter called the "Assignee"), the entire right, title and interest, for the United States, in and to certain inventions relating to

**SILICON-BASED FILM FORMATION PROCESS, SILICON-BASED FILM, SEMICONDUCTOR DEVICE, AND SILICON-BASED FILM FORMATION SYSTEM**

and described in an application for Letters Patent of the United States filed by us on June 12, 2002

and which has been accorded Application No. 10/166,759

and in and to said application, and all divisions, and continuations thereof, and all Letters Patent of the United States which may be granted, thereon, and all reissues and extensions thereof; and we hereby authorize and request the Commissioner of Patents and Trademarks of the United States to issue all Letters Patent upon said inventions to the Assignee or to such nominees as it may designate.

AND we authorize and empower the said Assignee or nominees to invoke and claim for any application for patent or other form of protection for said inventions filed by it or them, the benefit of the right or priority provided by the International Convention for the Protection of Industrial Property, as amended, or by any convention which may henceforth be substituted for it, and to invoke and claim such right of priority without further written or oral authorization from us.

AND we hereby consent that a copy of this assignment shall be deemed a full legal and formal equivalent of any assignment, consent to file or like document which may be required in the United States for any purpose and more particularly in proof of the right of said Assignee or nominees to claim the aforesaid benefit of the right of priority provided by the International Convention for the Protection of Industrial Property, as amended, or by any convention which may henceforth be substituted for it.

AND we hereby covenant that we have the full right to convey the entire right, title and interest herein assigned and that we have not executed and will not execute any agreement in conflict herewith.

AND we hereby covenant and agree that we will communicate to said Assignee or nominees all facts known to us pertaining to said inventions, and testify in all legal proceedings, sign all lawful papers, execute all continuing and reissue applications, make all rightful oaths and declarations and in general perform all lawful acts necessary or proper to aid said Assignee or nominees in obtaining, maintaining and enforcing all lawful patent protection for said inventions in the United States.

By: Takaharu Kondo  
Takaharu Kondo

Date: July 11, 2002

By: Masafumi Sano  
Masafumi Sano

Date: July 15, 2002

By: Akira Sakai A.S.  
Akira Sakai

Date: July 16, 2002

By: Tadashi Sawayama  
Tadashi Sawayama

Date: July 21, 2002

By: Ryo Hayashi  
Ryo Hayashi

Date: July 11, 2002

By: Shuichiro Sugiyama  
Shuichiro Sugiyama

Date: July 15, 2002

By: Hiroiyuki Ozaki  
Hiroiyuki Ozaki

Date: July 15, 2002

By: Yoshinori Sugiura  
Yoshinori Sugiura

Date: July 15, 2002

By: \_\_\_\_\_

Date: \_\_\_\_\_

By: \_\_\_\_\_

Date: \_\_\_\_\_

By: \_\_\_\_\_

Date: \_\_\_\_\_

By: \_\_\_\_\_

Date: \_\_\_\_\_

By: \_\_\_\_\_

Date: \_\_\_\_\_

By: \_\_\_\_\_

Date: \_\_\_\_\_